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5	Substitute for form 1449B/PTO				Complete if Known			
					Application Number	10/646,013		
	INFOR	MATION	DISCLO	SURE	Filing Date First Named Inventor	8/22/2003		
	STATE	MENT B	Y APPL	ICANT		Cheng H. Huang		
					Art Unit	2826		
	(t	ise as many shee	ts as necessar)	1)	Examiner Name	Remmon R. Forde		
	Sheet	1	of	1	Attorney Docket Number	A1063		

		NON PATENT LITERATURE DOCUMENTS					
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Îl- X.		V. KLEE et al. "A 0.13 um logic-based embedded DRAM technology with electrical fuses, Cu interconnect in SiLK, sub-7ns random access time and its extension to the 0.10 um generation," IEEE (c) 2001 IEDM (International Electron Devices Meeting), Technical Digest, pp 18.5.1-18.5.4					
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Substitute	for form 1449B/PTO			Complete if Known			
				Application Number	10/646,013		
INFO	RMATION	DISCLO	SURE	Filing Date	8/22/03		
STA	TEMENT BY	Y APPLI	CANT	First Named Inventor	Cheng H. Huang et al.		
				Art Unit	2811		
	(Use as many sheet	ls as necessary)		Examiner Name	Remmon R. Forde		
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1		WEI ZHANG et al., "Reliability of laser-induced metallic vertical links,"							
16.79		IEEE Trans. on Advanced Packaging, pp 614-19 Nov 1999 Vol. 22 Issue							
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1 2	JB BERNSTEIN et al. "Laser energy limitation for buried metal cuts"								
\(\(\psi\)\.		IEEE Electron Device Letters, pp 4-6, Jan. 1998, Vol. 19, Issue 1							
1. %		RT SMITH et al. "Laser programmable redundancy and yield improvement in a 64 K DRAM", IEEE Journal of Solid-State Circuits, pp 506-514 October 1981, Vol. 16, Issue 5							
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